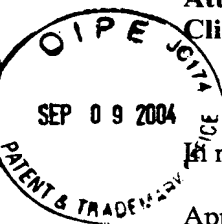


Attorney Docket No. 071469-0308624

Client Reference: ES-039

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Is re application of: HONGYU YUE, ASAO YAMASHITA

Application No.: 10/813,570

Confirmation No: 4336

Filed: March 31, 2004

Group No.: 2812

Examiner Not Yet Assigned

For: System and Method for Etching a Mask

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET

37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: HONGYU YUE

Citizenship: PEOPLE'S REPUBLIC OF CHINA

Residence: Plano, TX 75025

Second applicant: ASAO YAMASHITA

Citizenship: JAPAN

Residence: Wappingers Falls, NY 12590

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: System and Method for Etching a Mask

Docket number assigned to this application: 071469-0308624

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 15

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

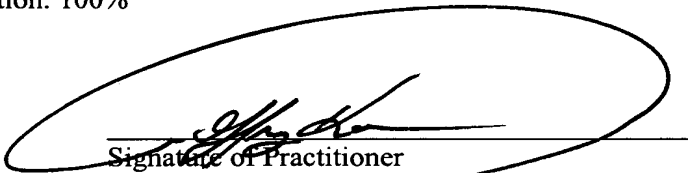
The assignee(s) of this application is/are:

Tokyo Electron Limited
3-6, Akasaka 5-chome, Minato-ku
Tokyo, 107
JAPAN

Extent of interest of assignee in application: 100%

Date: September 9, 2004

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